

Docket No.: D412

**OFFICIAL**  
**PATENT**  
**RECEIVED**  
**CENTRAL FAX CENTER****IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

NOV 03 2003

In re Application of:	Kai Yang, et al.	:	Confirmation No.:	1824
Serial No.:	09/663,021	:	Art Unit:	2815
Filed:	1/30/2003	:	Examiner:	Sheila V. Clark
For:	SELF-ALIGNED SEMICONDUCTOR INTERCONNECT BARRIER AND MANUFACTURING METHOD THEREFOR	:		

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**RESPONSE TO FINAL OFFICE ACTION  
AND REQUEST FOR RECONSIDERATION**

Madam:

The following Remarks are submitted in response to the Final Rejection mailed September 2, 2003. Applicants respectfully request reconsideration of the rejections.